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CONFIRMATION NO. 3669

<b>SERIAL NUMBER</b> 10/735,742	<b>FILING OR 371(c) DATE</b> 12/16/2003 <b>RULE</b>	<b>CLASS</b> 438	<b>GROUP ART UNIT</b> 2812	<b>ATTORNEY DOCKET NO.</b> 312973-P0083	
<b>APPLICANTS</b> Jae-Eun Lim, Ichon-shi, KOREA, REPUBLIC OF; Yong-Sun Sohn, Ichon-shi, KOREA, REPUBLIC OF;  <b>** CONTINUING DATA *****</b>  <b>** FOREIGN APPLICATIONS *****</b> REPUBLIC OF KOREA 2003-51086 07/24/2003  <b>IF REQUIRED, FOREIGN FILING LICENSE GRANTED</b> <b>** 03/22/2004</b>					
Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Allowance Verified and Acknowledged		<b>STATE OR COUNTRY</b> KOREA, REPUBLIC OF	<b>SHEETS DRAWING</b> 6	<b>TOTAL CLAIMS</b> 20	<b>INDEPENDENT CLAIMS</b> 2
<b>ADDRESS</b> 47604					
<b>TITLE</b> Method for manufacturing shallow trench isolation in semiconductor device					
<b>FILING FEE RECEIVED</b> 770	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		